

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Mitsuru TAKAI et al.

Group Art Unit: 284は こしつり

Appln. No. : 10/084,177

Examiner: Hadi AKHVANNIK

Filed

: February 28, 2002

Conformation No.: 4788

For

: NEXT PROCESS-DETERMINING METHOD, INSPECTING METHOD

AND INSPECTING APPARATUS

## COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Commissioner for Patents U.S. Patent and Trademark Office Customer Service Window, Mail Stop Issue Fee Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

In response to the Notice of Allowability, mailed by the U.S. Patent and Trademark Office on July 28, 2006, and to the Statement of Reasons for Allowance attached thereto, Applicants wish to clarify the record with respect to the basis for the patentability of claims in the present application. While Applicants do not disagree with the Examiner's indication that certain identified features are not disclosed by the references, Applicants submit that each of the claims in the present application recite a particular combination of features, and that the basis for patentability of each of these claims is based on the totality of the particular features recited therein.

Should there be any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully submitted, Mitsuru TAKAI et al.

Bruce H. Bernstein Reg. No. 29,027

October 27, 2006 GREENBLUM & BERNSTEIN, P.L.C. 1950 Roland Clarke Place Reston, VA 20191 (703) 716-1191 Steven Wegman

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